Sir:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814 Examiner: Phat Cao

| In Re PATEN | T APPLICATION Of: | |
|---|--|-----------------------|
| Applicant: | KUMAMOTO et al. |) |
| Serial No: | 10/767,439 |) |
| Filed: | January 30, 2004 |))) AMENDMENT |
| For: | SEMICONDUCTOR CHIP AND PRODUCTION PROCESS THEREFOR |) |
| Docket No.: | AI 318 D1 | December 13, 2005 |
| Commissione P.O. Box 1450 Alexandria, V | | |

Responsive to the Examiner's Action dated September 22, 2005, please amend the application as follows:

ZFW